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## **CONFIRMATION NO. 4799**

SERIAL NUMBEI 10/689,617	FILING DATE 10/22/2003 RULE	(	CLASS 438		PART UNIT	[	ATTORNEY OOCKET NO. 2732-170001
APPLICANTS							
Satoru Okamoto, Isehara, JAPAN;							
** CONTINUING DATA **********************************							
** FOREIGN APPLICATIONS ************************************							
Foreign Priority claimed			STATE OR	SHEE	гѕ то	TAL	INDEPENDENT
met Verified and	Allowance	itials	COUNTRY JAPAN	DRAWI 9		IMS 5	CLAIMS 13
ADDRESS 26171 FISH & RICHARDSON P.C. P.O. BOX 1022 MINNEAPOLIS , MN 55440-1022							
Method for cleaning plasma etching apparatus, method for plasma etching, and method for manufacturing semiconductor device							
FILING FEE No to charge/credit DEPOSIT ACCOUNT No for following:    All Fees     1.16 Fees (Filing)     1.17 Fees (Processing Ext. of time)     1.18 Fees (Issue)							essing Ext. of